

<b>Notice of References Cited</b>	Application/Control No. 10/582,168		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner William C. Doerrler		Art Unit 3744	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,642,622	07-1997	Berchowitz et al.	62/6
*	B	US-5,907,956	06-1999	Arima et al.	62/148
*	C	US-5,921,092	07-1999	Behr et al.	62/81
*	D	US-6,301,913	10-2001	Schulak et al.	62/248
*	E	US-2001/0039802	11-2001	Barrash, Marshall J.	62/6
*	F	US-2004/0089012	05-2004	Chen et al.	062/277
*	G	US-2005/0016184	01-2005	Zhang et al.	062/006
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.